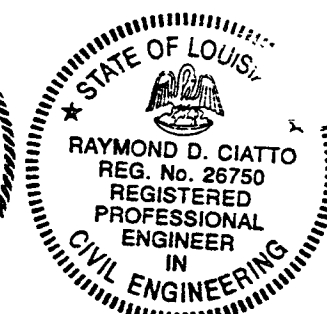
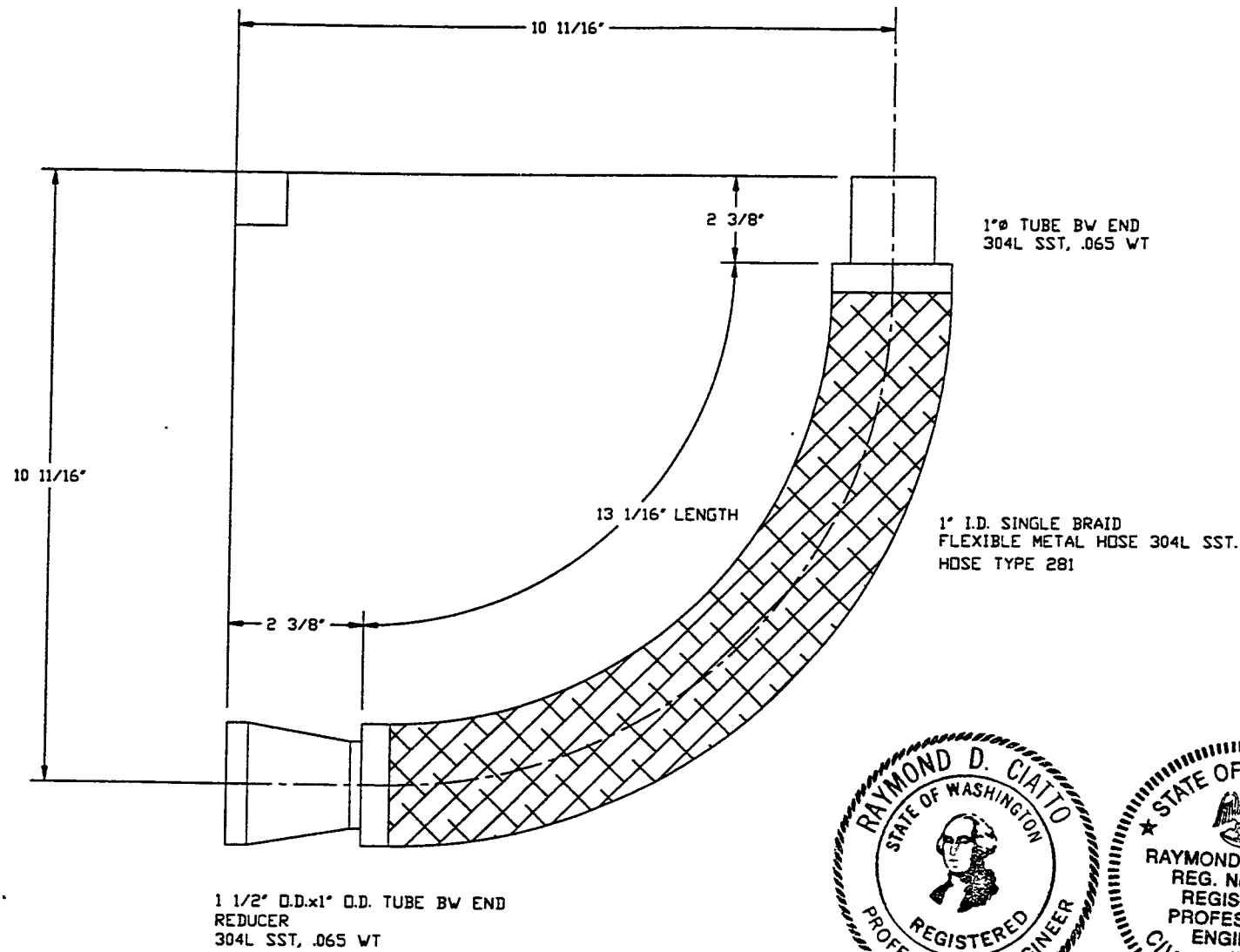


NOTES: MANUFACTURING, CLEANING AND PACKAGING REQUIREMENTS PER SPEC. V049-4-037/T4

DESIGN PRESSURE: VACUUM 10 TOR TO 2 PSIG
 DESIGN TEMPERATURE: -20°F TO 150°F
 CORROSION ALLOWANCE: ZERO



Raymond D. Ciatto, P.E.
 9/9/96

LIGO-D970429-00-V

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DWG. NO.	DESCRIPTION	USED ON	REV.	DESCRIPTION	CHKD	DRAWN	DATE	DEC
	REFERENCE DRAWINGS							
		NEXT ASS'Y: D V049-4-054	0	ISSUED FOR FABRICATION			7/29/96	0230

PROCESS SYSTEMS INTERNATIONAL, INC. 20 WALTON DR. WESTBORO, MA, MASSACHUSETTS 01581 USA			
HAM ANNULUS FLEX HOSE			
LIGO VACUUM EQUIPMENT			
CAD FILE V0494129	SIZE C	DWG. NO. V049-4-129	REV. 0
SCALE 3"=1'-0"		SHEET 1 OF 1	

Jul 29, 1996 - 13:43:23